	Application No.	Applicant(s)	,
	10/668,435	10/668,435 VERDONK ET AL.	
Notice of Allowability	Examiner	Art Unit	- 1 JF J + N JN
	Samuel A Gebremariam	2811	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS In therewith (or previously mailed), a Notice of Allowance (PTOL-8 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1.3	S (OR REMAINS) CLOSED in 5) or other appropriate commun RIGHTS. This application is su	this application. If not includ nication will be mailed in due	led course. <b>THIS</b>
1. This communication is responsive to <u>9/22/2003</u> .			
2. ☑ The allowed claim(s) is/are <u>12-21</u> .			
3. X The drawings filed on 22 September 2003 are accepted	by the Examiner.		
4. Acknowledgment is made of a claim for foreign priority a) All b) Some* c) None of the:  1. Certified copies of the priority documents hat 2. Certified copies of the priority documents hat 3. Copies of the certified copies of the priority of International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:  Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  5. A SUBSTITUTE OATH OR DECLARATION must be sub INFORMAL PATENT APPLICATION (PTO-152) which gifted including changes required by the Notice of Draftspee 1) hereto or 2) to Paper No./Mail Date  (b) including changes required by the attached Examine Paper No./Mail Date  (b) including changes required by the attached Examine Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in The DEPOSIT OF and/or INFORMATION about the department of the priority documents and company to the department of the priority documents had company to the department of the priority documents had company to the priority of the priority	ve been received.  ve been received in Application documents have been received.  E" of this communication to file a IMENT of this application.  mitted. Note the attached EXAP ives reason(s) why the oath or out the submitted.  erson's Patent Drawing Review er's Amendment / Comment or in the header according to 37 CFR posit of BIOLOGICAL MATE	No in this national stage application this national stage application this national stage application the reply complying with the result of the claration is deficient.  ( PTO-948) attached In the Office action of the drawings in the front (not the 1.121(d).  RIAL must be submitted.	equirements  NOTICE OF
Attachment(s)  1. ☑ Notice of References Cited (PTO-892)		ormal Patent Application (PT	O-152)
<ol> <li>Notice of Draftperson's Patent Drawing Review (PTO-948</li> <li>Information Disclosure Statements (PTO-1449 or PTO/SB</li> </ol>	Paper No./M	mmary (PTO-413), lail Date .mendment/Comment	
Paper No./Mail Date  Paper No./Mail Date  Examiner's Comment Regarding Requirement for Deposit	, <u> </u>		owanoc
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## **DETAILED ACTION**

## **Allowance**

1. Claims 12-21 are allowed over prior art of record.

## Reason for Allowance

2. The following is an examiner's statement of reasons for allowance: The prior art of record does not teach or suggest, singularly or in combination at least the limitation "etching back a top surface of the CMOS fabricated photodetector array to form recessed regions at the locations of the photoemitter areas in order to reveal the buried electric contact pads; and inserting a plurality of discrete semiconductor photoemitter devices into the recessed regions of the CMOS fabricated photodetector array to make electrical contact with the revealed buried electric contact pads therein" as recited in claim 12 is a major difference between the prior art and the claimed process, and the second major difference between the prior art and the claimed process is "each photoemitter area including at least two buried electric contact pads, comprising steps of: locating photoemitter areas having electrical contact pads; inserting a plurality of discrete semiconductor photoemitter devices onto the photoemitter regions of the CMOS fabricated photodetector array to make electrical contact with the electric contact pads" as recited in claim 19.

## Conclusion

 The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. References A-D are cited as being related to a process of making optical devices. Application/Control Number: 10/668,435

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Samuel A Gebremariam whose telephone number is (571)-272-1653. The examiner can normally be reached on 8:00am-4:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Eddie Lee can be reached on (571) 272-1732. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

SAG July 11, 2004

ORI NADAV
patent examines